

APR 10 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Haupt Docket No.: INTECH 3.0-104
(2003 P 51718 US)
Filed: 1/28/2004
Examiner: Thanh Y. Tran
Serial No.: 10/766,053
Art Unit: 2822
Title: Method for N+ Doping of Amorphous Silicon and Polysilicon Electrodes in Deep Trenches

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicant wishes to bring to the attention of the U.S. Patent and Trademark Office the information noted on the enclosed PTO Form PTO/SB/08A, which may be considered material to the examination of the above-identified application. Copies of the U.S. Patents cited are not being submitted.

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Respectfully submitted,

04/11/2006 EAYALEW1 00000038 501065 10766053

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Mark E. Courtney
Attorney for Applicant
Reg. No. 36,491

Slater & Matsil, L.L.P.
17950 Preston Road, Suite 1000
Dallas, Texas 75252
Tel: (972) 732-1001
Fax: (972) 732-9218

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